

Measurement of Charge Collection in Active Pixels in irradiated AMS Chess 1 HVCmos prototype

ATLAS Strip CMOS Regular Meeting, 29 March 2016

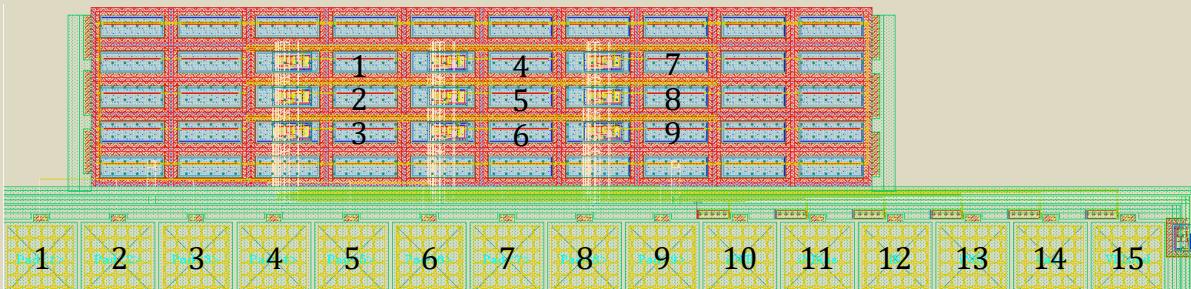
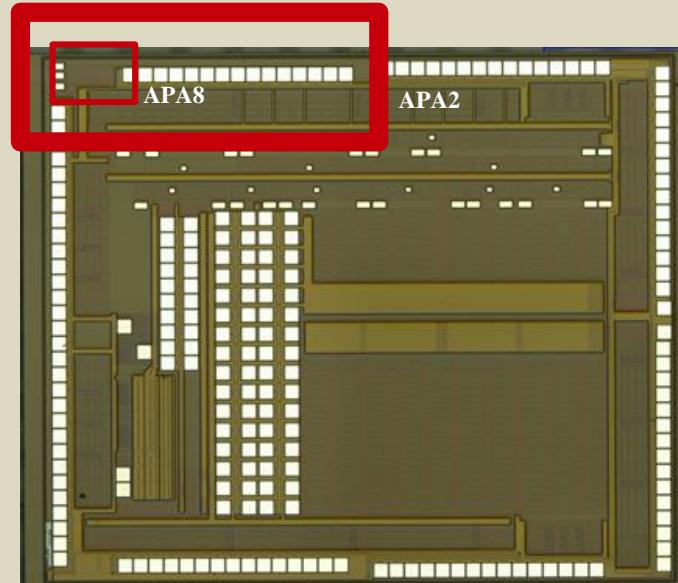
Bojan Hiti, Igor Mandić et al.

Jožef Stefan Institute, Experimental Particle Physics Department (F9)

AMS CHESS 1 Sample

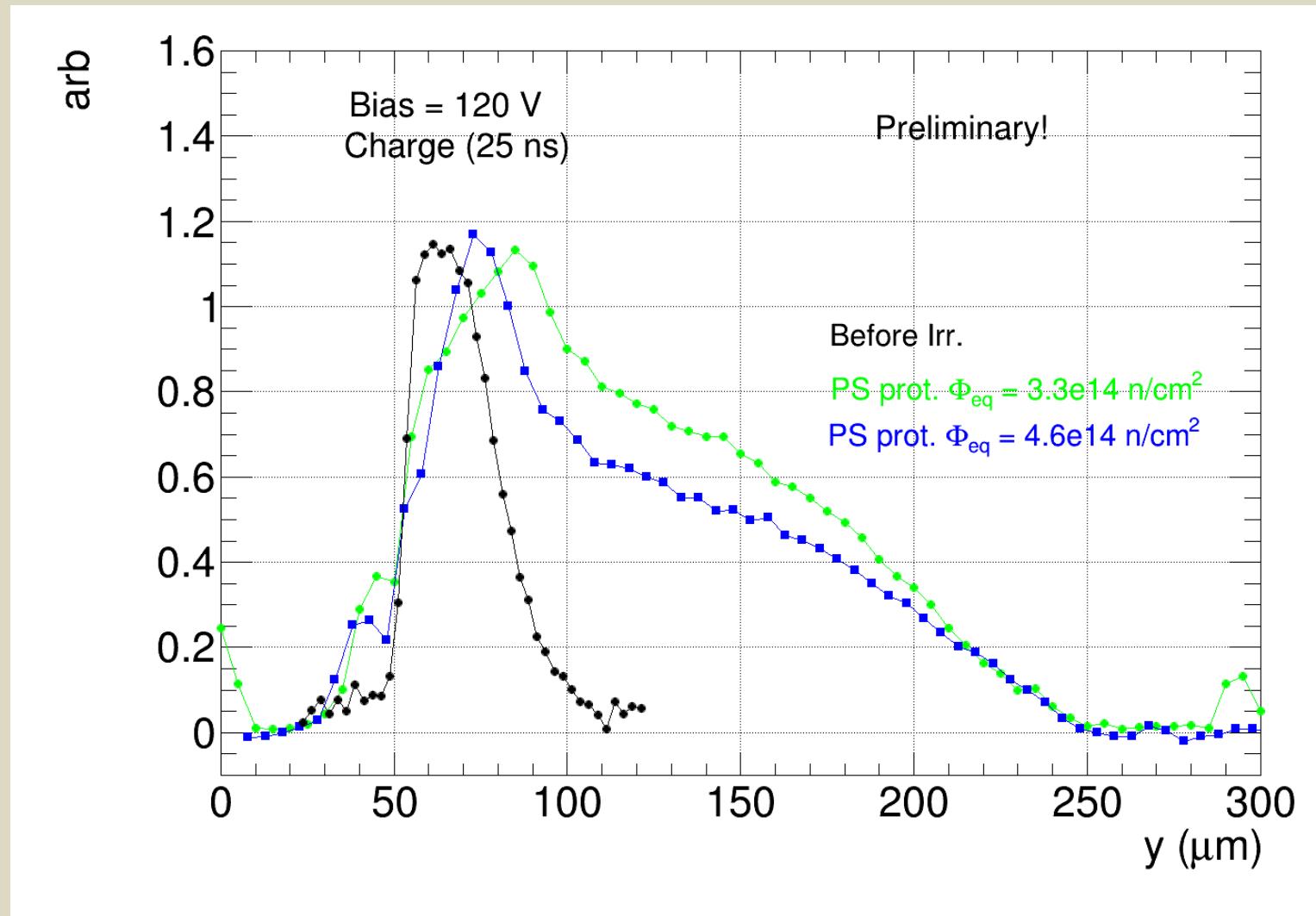


- 350 nm, 20 Ω , max. bias voltage 120 V, active pixels
- passive pixel array for e-TCT:
 - 3x3 pixels, 100 x 45 μm^2
- active pixel arrays (APAs) for edge TCT:
 - APA02: 3x3 pixels, 100 x 45 μm^2
 - APA08: 3x3 pixels, 800 x 45 μm^2 ←
- Irradiated at CERN PS in November 2015
 - low fluence (1 sample) – 3.5e14 neq cm $^{-2}$
 - high fluence (1 sample) – 4.8e14 neq cm $^{-2}$
 - not annealed



layout of a 3x3 APA (200 x 45 μm^2)

Passive Pixel Array – Depletion Depth



Depleted region increases after irradiation



Global DAC Settings

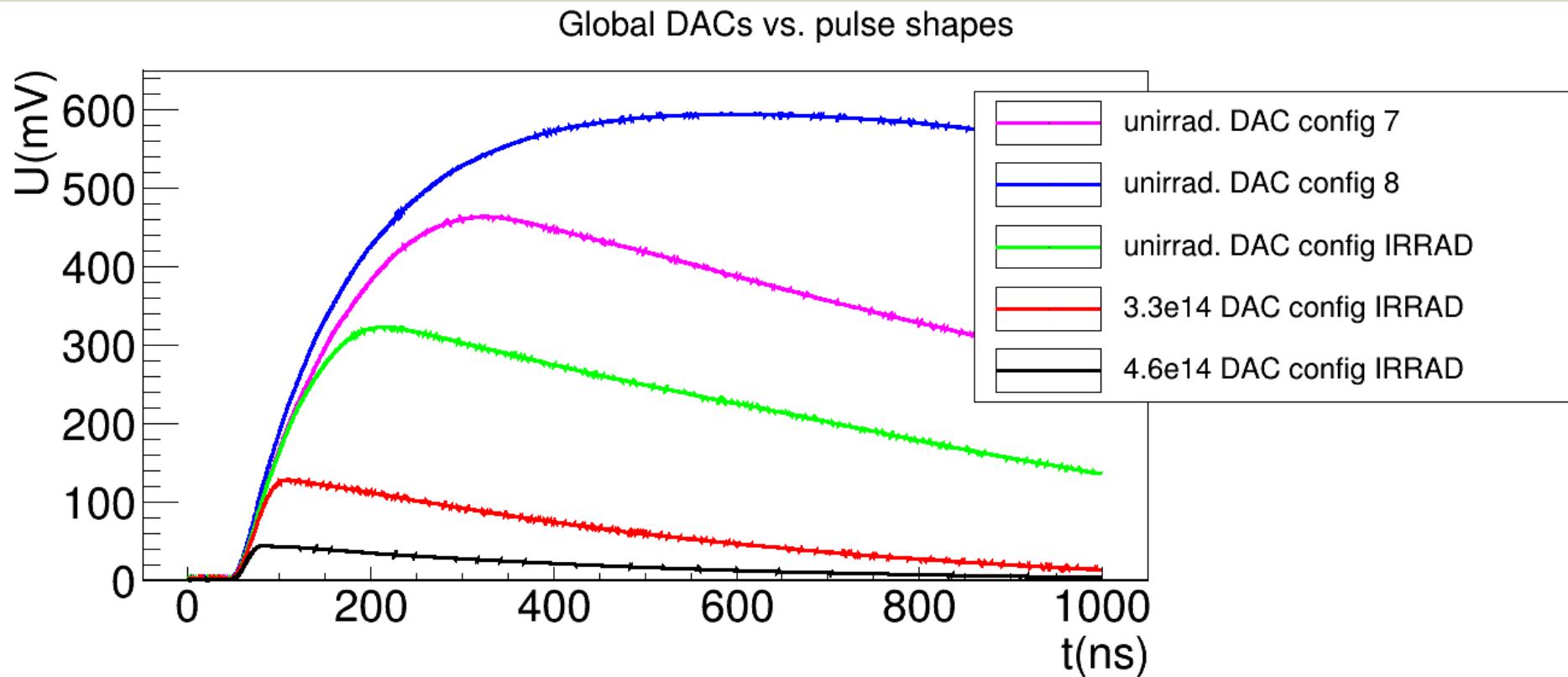
- Chip DACs need tuning to see the signal
 - For VPFB > 2500 amplifier output disappears
 - For VPFB > 2700 very small negative pulse observed
- Greater laser power compared to unirradiated sample needed

CONFIG 7		CONFIG 8 (standard)		CONFIG IRRAD	
VPLOAD	2100	VPLOAD	2100	VPLOAD	2100
VCASC	2600	VCASC	2600	VCASC	2600
VNSF	570	VNSF	750	VNSF	570
VN	1000	VN	1000	VN	1000
VBIAS	340	VBIAS	150	VBIAS	300
VPFB	2664	VPFB	2700	VPFB	2500

Gain after Irradiation



- Pulse shape on 3 different samples measured (unirrad., low fl., high fl.)
- Same amount of light injected
- 120 V bias

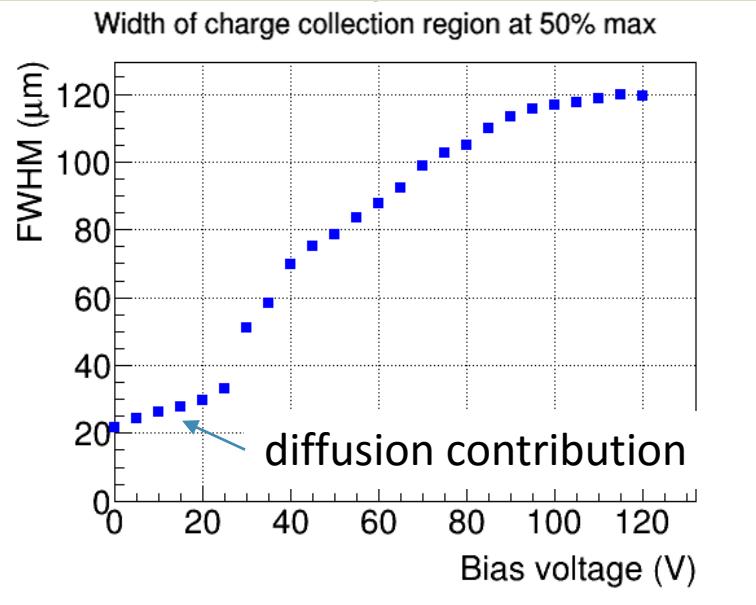


Gain reduces drastically with irradiation (amplifier degradation)

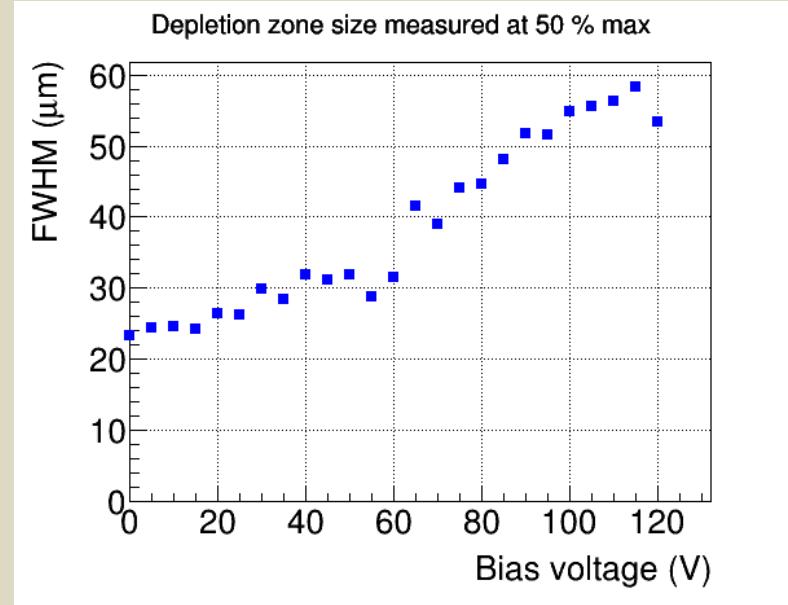
Depletion depth in APA 08



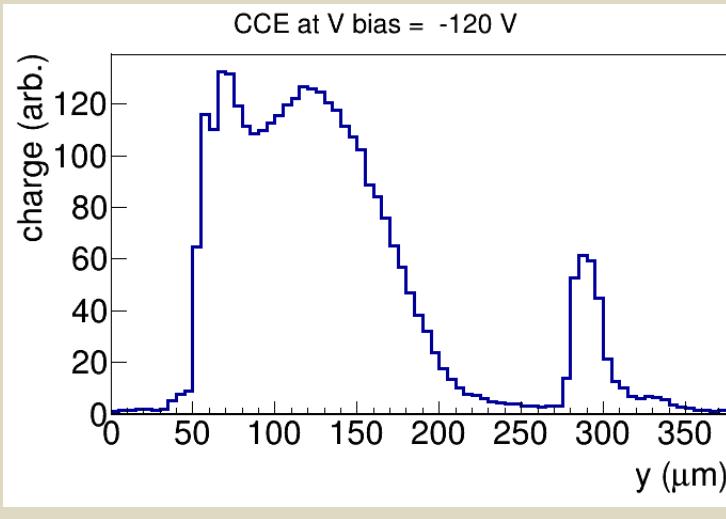
low fluence



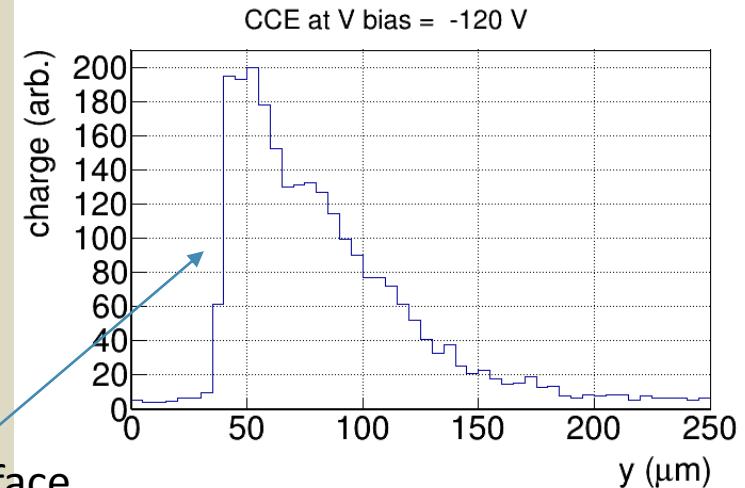
high fluence



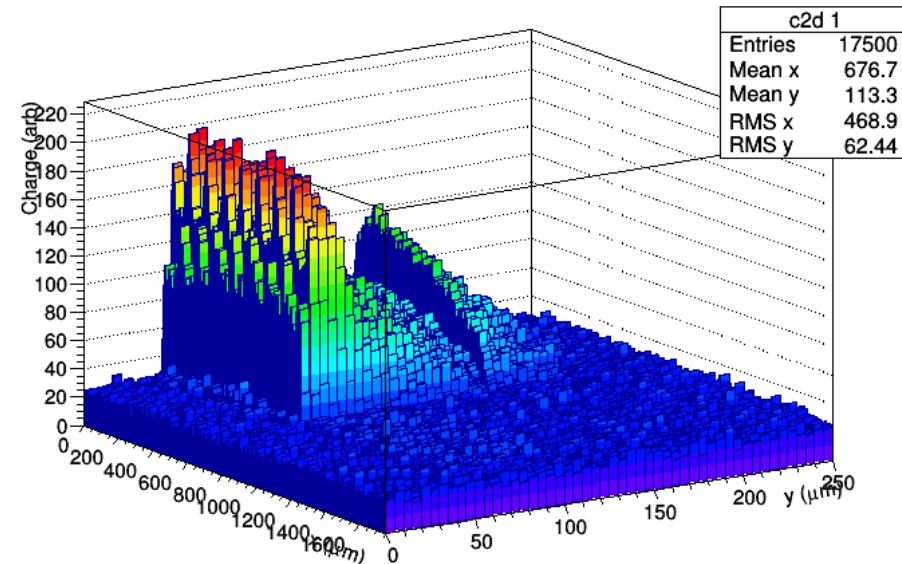
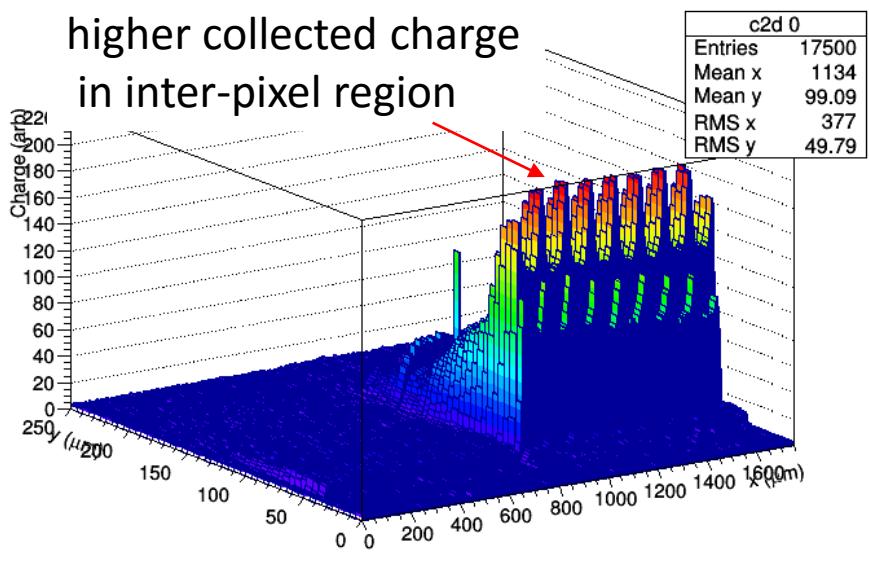
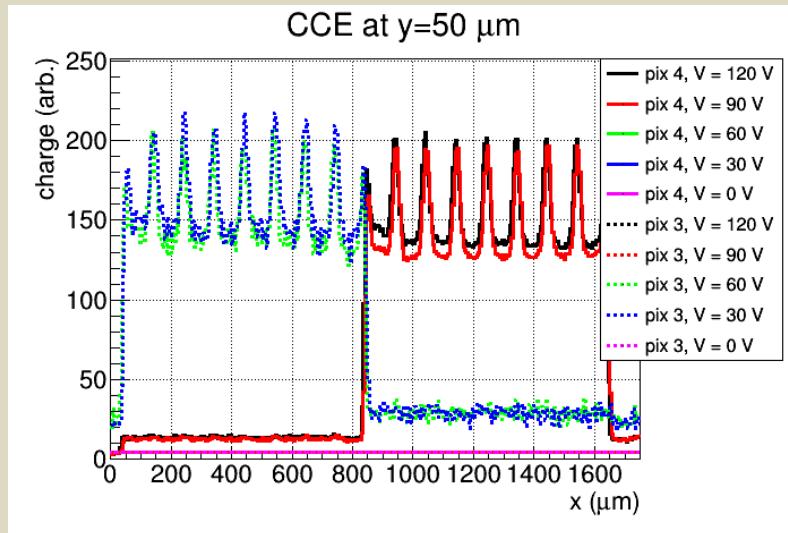
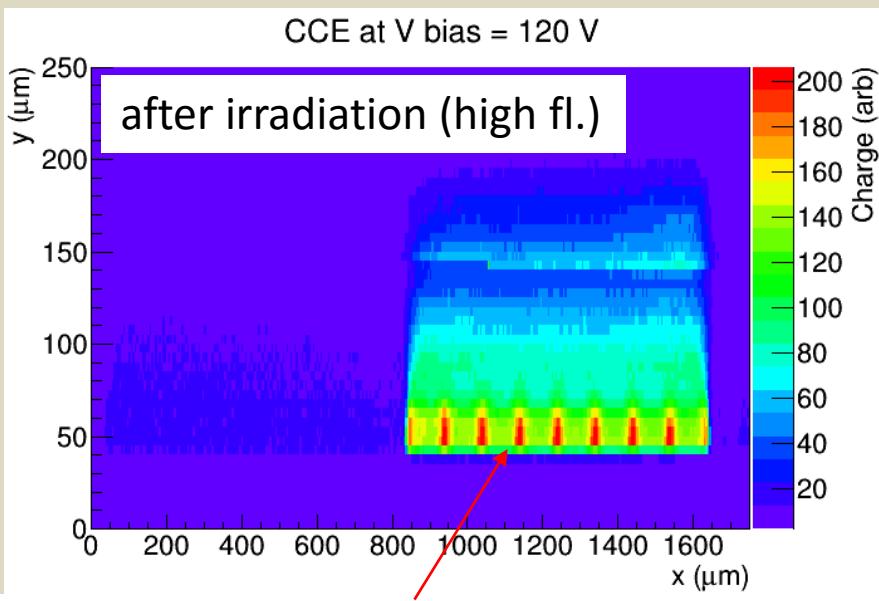
CCE at V bias = -120 V



CCE at V bias = -120 V



APA08, 2d Scan

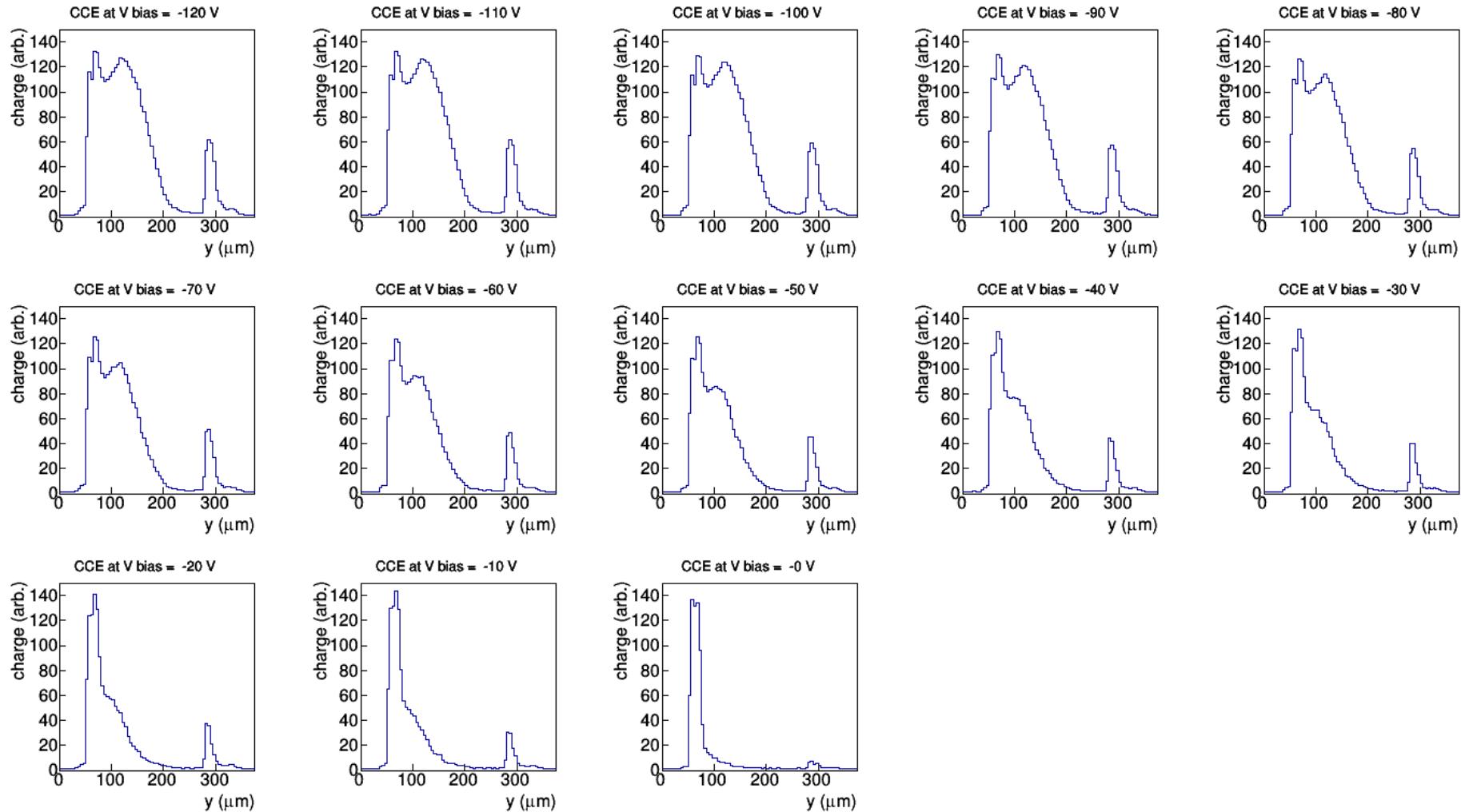


Conclusion



- Signal in irradiated devices found, but require specific **DAC settings** and **high laser power**
- Depletion regions grows with irradiation
- Next steps:
 - measure amplifier gain on irradiated samples (isolated amplifier)
 - annealing

Charge collection profiles – low fluence



Charge collection profiles – high fluence

